		U.S. DEPARTMENT O	E COMMERCE	ATTY DOCKET NO.		SERIAL NO.			
Form PTO 1449 (Modified)		U.S. DEPARTMENT OF PATENT AND TRADE	MARK OFFICE	250619US2SRD DIV		NEW APPLICATION			
				APPLICANT					
UST OF I	REFER	ENCES CITED BY APP	LICANT		ideyuki FUN	AKI_			
LIGI OF	\ <u></u>			FILING DATE	GROUP				
•				Herewith					
<u> </u>				U.S. PATENT DOCUMENTS		L			
				1		SUB	FILIN	NG DATE	
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	CLASS	IF APP	ROPRIATE	
HIL	AA	5,880,921	3/9/99	J. L. Julian THAM, et al.					
/ VN	AB					ļ			
	AC					ļ			
	AD	:						<del></del>	
	AE					<u> </u>			
	AF								
	AG	<u> </u>	<del>                                     </del>						
	AH								
	Al							<u>:</u>	
	AJ					·			
	AK		<del> </del>						
			<del> </del>						
	AL		-						
	AM	<u></u>							
	AN			DREIGN PATENT DOCUMENTS			•		
			F(	DREIGN PATENT DOCUMENTS		<del></del>			
		DOCUMENT NUMBER	DATE	COUNTRY	<u>.</u>	TRANSLATIO YES		NO	
	ÃO								
<del></del>	AP					<u> </u>			
	AQ				•				
	AR								
	AS				•	<u> </u>	<u>_</u>		
	AT							· · ·	
	AU		:						
	AV		<del> </del>						
	1 ~~	OTHER DE	EEDENCES	(Including Author, Title, Date, Pe	ertinent Pages.	etc.)			
		A 1 50 0 15	F F D	High O Micromochanical Res	onators" TECH	NICAL DIG	EST. 12TH		
MH	AW	INTERNATIONAL IEE	E MICRO EL	ECTRO MECHANICAL STSTEMS	CONFERENCE	-, January	17-21, 100	o, pgs. 400 10	
1		Paul M. Zavracky, et a	I., "Micromed	hanical Switches Fabricated Using	Nickel Surface	Micromach	ining", JOL	JRNAL OF	
MA	AX	MICROELECTROMEC	HANICAL S	YSTEMS, VOL. 6, NO. 1, March 19					
	AY								
	AZ					dditional Re	ferences s	heet(s) attach	
Examiner	<u> </u>	MINOllo	con I	ears	Date (	Date Considered 05/3/05			
<b></b>	nitial id	reference is considered	whether or n	of citation is in conformance with N	MPEP 609; Drav	v line throu	gh citation	if not in	
conformance	niliai ii` e and n	ot considered. Include a	ppy of this for	m with next communication to app	licant.				

Form PTO 1449	U.S. DEPARTMENT OF COMMERCE			ATTY DOCKET NO.	SERIAL NO.				
(Modified)	•	PATENT AND TRADE	EMARK OFFICE	250619US2SRD DIV	New Application				
,		•		APPLICANT					
LIST OF REFERENCES CITED BY APPLICANT Hideyuki FUNAKI									
·				FILING DATE	GROUP				
				Herewith					
				U.S. PATENT DOCUMENTS					
EXAMINER		DOCUMENT			T	SUB	FILING DATE		
INITIAL		NUMBER	DATE	NAME .	CLASS	CLASS	IF APPROPRIATE		
MA	AA	6,153,839	11/2000	Zavracky et al.	<u> </u>				
	AB								
	AC		-		ļ				
	AD					1			
	AE	i							
	AF				<u> </u>				
	AG								
	AH								
	ΑI								
	AJ								
	AK								
	AL								
	AM								
	AN								
			FC	REIGN PATENT DOCUMENTS					
		DOCUMENT NUMBER				TRANSLATION			
		NUMBER				YES	S NO		
	AO					-			
	AP		ļ			-			
	AQ					<del> </del>			
	AR		<u> </u>			<u>-</u>			
	AS					<del> </del>			
·	AT	-		<u> </u>					
	AU								
	AV					ļ <u>.</u>			
		OTHER RE	FERENCES	(Including Author, Title, Date, Pertiner	nt Pages, e	tc.)			
	AW	·							
	AX								
	AY								
	AZ				Add	itional Refe	erences sheet(s) attached		
Examiner Malluml				V	Date Considered 05/03/05				
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									